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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Izumi FUSEGAWA et al.

Group Art Unit: 1722

Application No.: 10/568,186

Docket No.: 126961

Filed: March 3, 2006

For: METHOD FOR PRODUCING A SINGLE CRYSTAL AND SILICON SINGLE  
CRYSTAL WAFER

**REQUEST FOR CORRECTION OF PALM RECORDS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

William P. Berridge  
Registration No. 30,024

Mario A. Costantino  
Registration No. 33,565

WPB:MAC/cab

Date: October 19, 2006

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

<p><b>DEPOSIT ACCOUNT USE AUTHORIZATION</b> Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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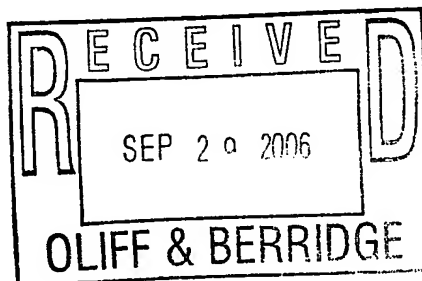
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/568,186	03/03/2006	1722	1030	126961	5	17	2

25944  
 OLIFF & BERRIDGE, PLC  
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 ALEXANDRIA, VA 22320



CONFIRMATION NO. 5592  
 CORRECTED FILING RECEIPT



\*OC000000020608869\*

Date Mailed: 09/27/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

**Applicant(s)**

Izumi Fusegawa, Fukushima, JAPAN;  
 Nobuaki Mitamura, Fukushima, JAPAN;  
 Takahiro Yanagimachi, Fukushima, JAPAN;

mitamura

**Assignment For Published Patent Application**

Shin-Etsu Handotai Co., Ltd., Tokyo, JAPAN

**Power of Attorney:** The patent practitioners associated with Customer Number 25944.**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP04/11685 08/13/2004

**Foreign Applications**

JAPAN 2003-296837 08/20/2003

If Required, Foreign Filing License Granted: 07/20/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/568,186**

**Projected Publication Date:** 10/26/2006**Non-Publication Request:** No**Early Publication Request:** No

**Title**

Method for producing a single crystal and silicon single crystal wafer

**Preliminary Class**

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